



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Mao-Yi CHANG et al. Confirmation No: 1409
Appl. No. : 10/635,489
Filed : August 7, 2003
Title : METHOD FOR TRANSFORMING AN AMORPHOUS
SILICON LAYER INTO A POLYSILICON LAYER

TC/A.U. : 2818
Examiner : D. Vu

Docket No.: : CHAN3214/REF
Customer No: : 23364

PETITION FOR EXTENSION OF TIME

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Applicants request that the period for response to the outstanding official action in this case be extended pursuant to 37 CFR 1.136 (a) for ONE (1) month to June 18, 2005.

The fee set in 37 CFR 1.17(a)(1) for a one month extension of time is \$120.00 and a check in this amount is submitted herewith. Please charge any additional fee required for this extension to Deposit Account No. 02-0200. A duplicate copy of this paper is attached.

Respectfully submitted,

BACON & THOMAS, PLLC

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REF:kdd
EXT-LRG.1EX.wpd

June 16, 2005